Optimized algorithm to reduce the near-field measurement time on FPGA device
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Abstract — This paper presents a sequential adaptive sampling algorithm in order to reduce the measurement time of near-field scan. The originality of this approach is to use a deterministic mesh swept according to a sequential progressive adaptive algorithm that defines whether a point must be captured or not. All the proposed algorithm parameters are set according to spatial field characteristics and the measurement setup. This approach is validated on the measurement of the magnetic field produced in near-field region by a FPGA device.

Keywords — EMC, NFS, Near-Field Scanning, measurement, emission, adaptive sampling

I. INTRODUCTION

With the current industrial economic constraints, it is necessary to evaluate electromagnetic behavior of an electronic device as early as possible in development process. If the simulation tools fail to predict effectively the electromagnetic compatibility (EMC) of complex equipment, the EMC engineer must have efficient investigation tools based on measurements. Since many years, the near-field scanning (NFS) approach applied on electronic devices is developed. The NFS performances increase industrial’s interest for this EMC investigation measurement method. Limited to a robot moving a probe, the cost of NFS test bench is not expensive. The measurement is done above an electronic device. It is not strongly influenced by the set-up of equipment which ensures a high reproducibility of measurement (<1dB).

Despite these qualities, the first limitation of the NFS measurement method, backed-up by the industrial, is the measurement time. In a debug context, capturing only one field component (Hz) around a particular frequency is sufficient to investigate root cause of the EMC issue. However, in other conditions, characterizing a complex industrial electronic devices may require higher measurement time. For example, if a 200x150mm aeronautic calculator is used, the measurement (<1dB).

The orientation retained in this paper is to reduce the number of measurement points by capturing only points which bring the most information selected by a low time consuming algorithm based on the magnetic near-field characteristics. After a brief review of the principles of the sequential adaptive spatial sampling process in section II, the proposed algorithm is described in section III. In section IV and V, validation cases are presented which highlight the performances in terms of reduction of sampling point number and measurement error compared to a full scan.

II. SPATIAL ADAPTIVE SAMPLING ALGORITHM

The algorithm used for this study is described in [1]. In summary, this algorithm is based on a progressive sequential meshing as defined in Fig. 1. The total mesh grid ? is built at the beginning and it is scanned progressively according to the selection criterion that defined whether or not a point must be measured. A good sample must reduce the prediction error otherwise the sample is not captured. In other words, this selection criterion defines whether or not a sample at the position pi provides relevant information about the near-field produced by the DUT noted F.

The first step defines the final grid resolution ‘d’ of the regular meshing. d value will be set to the radius of the magnetic probe used for the measurement.

\[ d = r_{loop} \] (1)

The second step is to define the first meshing used to collect the initial dataset during the “Pass 0”. During this pass all points are captured. This dataset will be used to initialize the adaptive algorithm. The resolution of this initial meshing is defined by W as defined by the following equation where \( h_{meas} \) is the height of measurement.

\[ W \leq 2 \cdot h_{meas} \] (2)

With \( \Omega \subset \mathbb{R}^2 \), one can bound \( \Omega \) in the planar surface by \( \{ A_x, A_y \} \) which defines the width of \( \Omega \) respectively in x and y axes. The number of points N collected during the initial meshing (Pass 0) is defined by the following expression.

\[ N = \left\lfloor \frac{A_x}{W} + 1 \right\rfloor \cdot \left\lfloor \frac{A_y}{W} + 1 \right\rfloor \] (3)

A progressive spatial sweep is done on a number of sequential pass Q. Q could be defined from d and W parameters according to the following equation where k is the biggest integer that validate \( \frac{W}{d} \geq 2^k \):

\[ Q = 2 \cdot k + 1 \] (4)
On each pass, a reduced set of points are progressively covered. \( P_{q_{\text{max}}} = \{p_{qi}, q = 1...Q\}_{i=1}^{N_{q_{\text{max}}}} \) is defined to progressively cover \( \Omega \) at the final resolution \( d \). Let \( P_q \) the set of \( N_q \) sampling points swept on each pass \( q \) where \( N_q \leq N_{q_{\text{max}}} \). Note that both the evaluated number of points and spatial resolution are progressively increased pass after pass.

During the sweep of \( P_{q_{\text{max}}} \) points, the selection criterion is built to define whether or not the value of the radiated near-field \( F(p_{qi}) \) must be captured. The total number of collected points forms the final set \( F_M = \{F(p_i), pi \in \Omega\}_{i=1}^{M} \) where \( M = N + \sum_{q=1}^{Q} N_q \) define the total number of measurement points of \( F \) at the specific positions \( p_i \). The objective is to minimize \( M \), by ensuring that it allows to build an estimator that minimizes the prediction error of \( F \) at any position on \( \Omega \).

During iteration of \( N_{q_{\text{max}}} \) points during the pass \( q \), a selection criterion validates whether or not the value \( F(p_{qi}) \) must be measured. The definition of this criterion is the main point of this algorithm. This criterion is based on the standard deviation calculated from the known values of the points \( F_y = \{F(p_i)\}_{i=1}^{N_y} \) which neighbor \( p_{qi} \). The point \( p_{qi} \) is captured if \( \exists p_i \in F(p_i) > (F_y + 10dB) \). To increase the effect of the closest points to \( p_{qi} \), the mean value of the neighbors is weighted by the distance of each point \( p_i \) with \( p_{qi} \).

### III. CASE STUDY

#### A. Case study: Magnetic near-field measurement done on XILINX Spartan 6 FPGA device

Fig. 2 presents the test board. The frequency range starts at 5 MHz and goes up to 1.8 GHz. Two types of magnetic field probe are used: one for the Hx and Hy component and another for the Hz component. The spatial resolution of the probes is 0.5 mm. The signal captured by the probe is amplified by a 40dB low-noise amplifier and measured by a FSP R&S receiver. The probes are moved by a 3D scanner system at 2.5 mm above the top Printed Circuit Board (PCB) surface (1.1 mm above the top of FPGA package).

![Fig. 2. FPGA board description](image)

#### Fig. 3. Comparison between full sampling and optimized sampling from adaptive algorithm for Hy field @ 56.75MHz

![Fig. 3. Comparison between full sampling and optimized sampling from adaptive algorithm for Hy field @ 56.75MHz](image)
IV. VALIDATION

The main objective of this work is to reduce the measurement time. To reach this goal, we have proposed a progressive sequential adaptive algorithm in order to reduce the number of sampling points while minimizing the error on the reconstruction of $F$ over $\Omega$. After validation of the definition of W, we propose a discussion about these two points.

A. Definition of W from height of measurement

Fig. 3 presents the comparison between full sampling measurement at $d=0.5\text{mm}$ and optimized sampling measurement using adaptive algorithm for Hy magnetic field components process at 1.1mm above the FPGA. Note for ease of understanding, all magnetic field maps are displayed for the same magnitude range for the given field component. The main objective of this work is to reduce the measurement time. To reach this goal, we have proposed a progressive sequential adaptive algorithm in order to reduce the number of sampling points while minimizing the error on the reconstruction of $F$ over $\Omega$. After validation of the definition of W, we propose a discussion about these two points.

To calculate the measurement time, we assume that it takes one second to measure one point in the selected frequency range. A constant speed of 20cm/s is supposed to compute the probe displacement time. So for each value of $W/Q$ parameters it is possible to calculate the acquisition time related to the near-field capture over $\Omega$ ($F_M$ dataset), the execution time of the algorithm and near-field probe displacement time are identified.

The displacement time of the probe is small compared to the acquisition time. This is the benefit of using a regular mesh (Sukharev grid) coupling to the progressive sequential sweep[1]. The distance between two consecutive points is minimized.

In all configurations, the algorithm time is lower than one second (~50ms ±10ms). So the most important contribution to the measurement time is the acquisition time.

In this case study, the measurement time is reduced to 19 minutes with our algorithm (using $W=2.5\text{mm}/Q=5\text{pass}$) compared to 1 hour and 22 minutes for full scan sampling (gain = 10x).

V. CONCLUSION

This paper proposes an iterative sequential adaptive sampling algorithm. This approach provides a gain of 10 on the measurement time compared to the full grid measurement, without introducing excessive measurement errors (absolute mean is <2dB).

We have proposed a selected criterion based on the characteristic of magnetic near-field magnitude. It would be necessary to validate this algorithm on more case studies including electric near-field measurement. The selected criterion is based on real data. Multi-frequency measurements and vector measurements have not been evaluated. In this case, the definition of a specific criterion would surely be necessary. The proposed adaptive algorithm is developed for the near-field emission measurement. But it could be easily extended to near-field measurement in immunity.

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